PATENT
03345-P0042A WWW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Johannes Kaeppeler, et al.
Serial No. - Pending	October 14, 2003
Title of Application:	Method For Depositing Especially Crystalline Layers From The Gas Phase Onto Especially Crystalline Substrates

Mail Stop Patent Application
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Cover Sheet For Ten Sheets Of Drawings

Attorney for Applicants
Wesley W. Whitmyer, Jr., Registration No. 33,558
ST.ONGE STEWARD JOHNSTON & REENS LLC
986 Bedford Street
Stamford, CT 06905-5619
203 324-6155

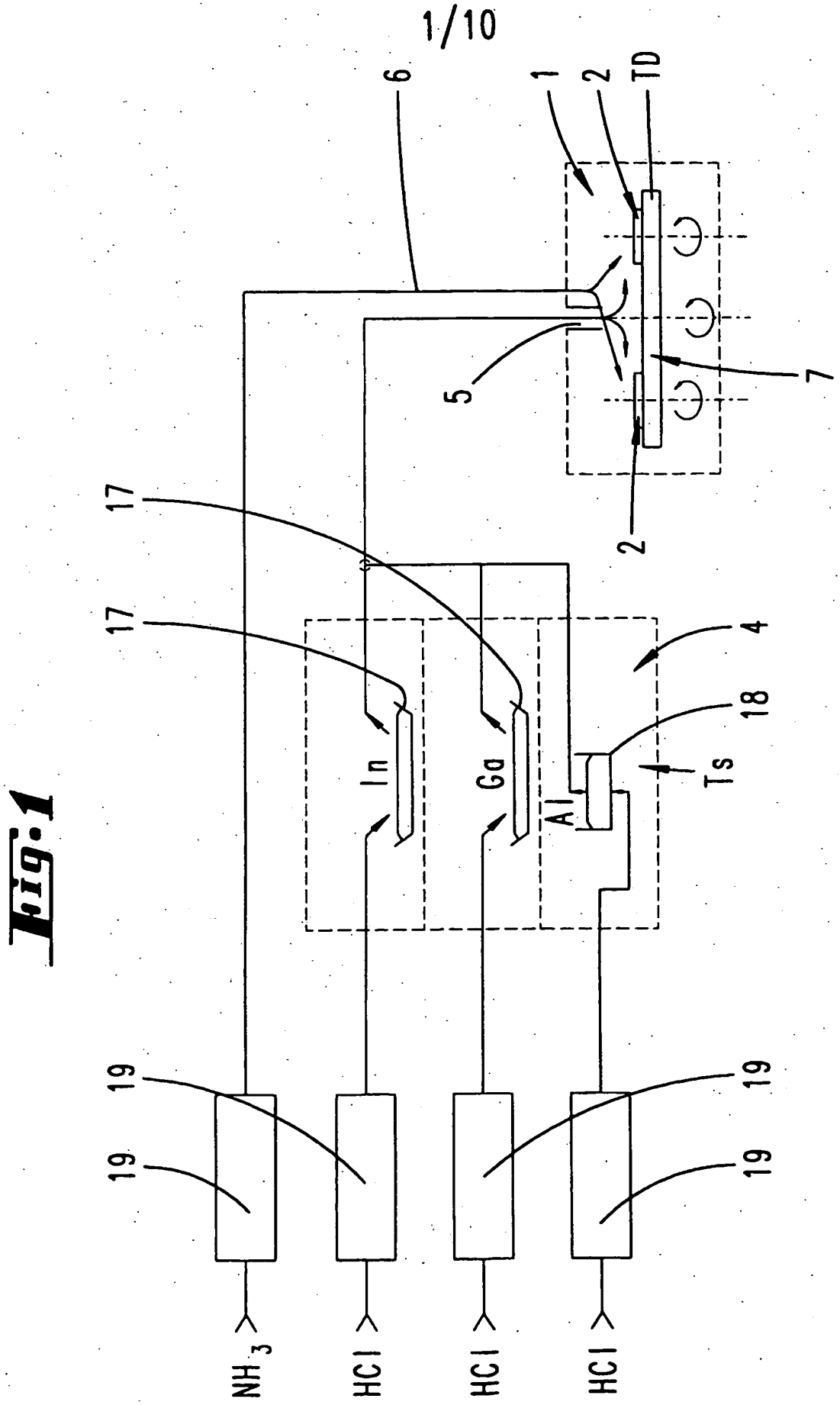


Fig:1

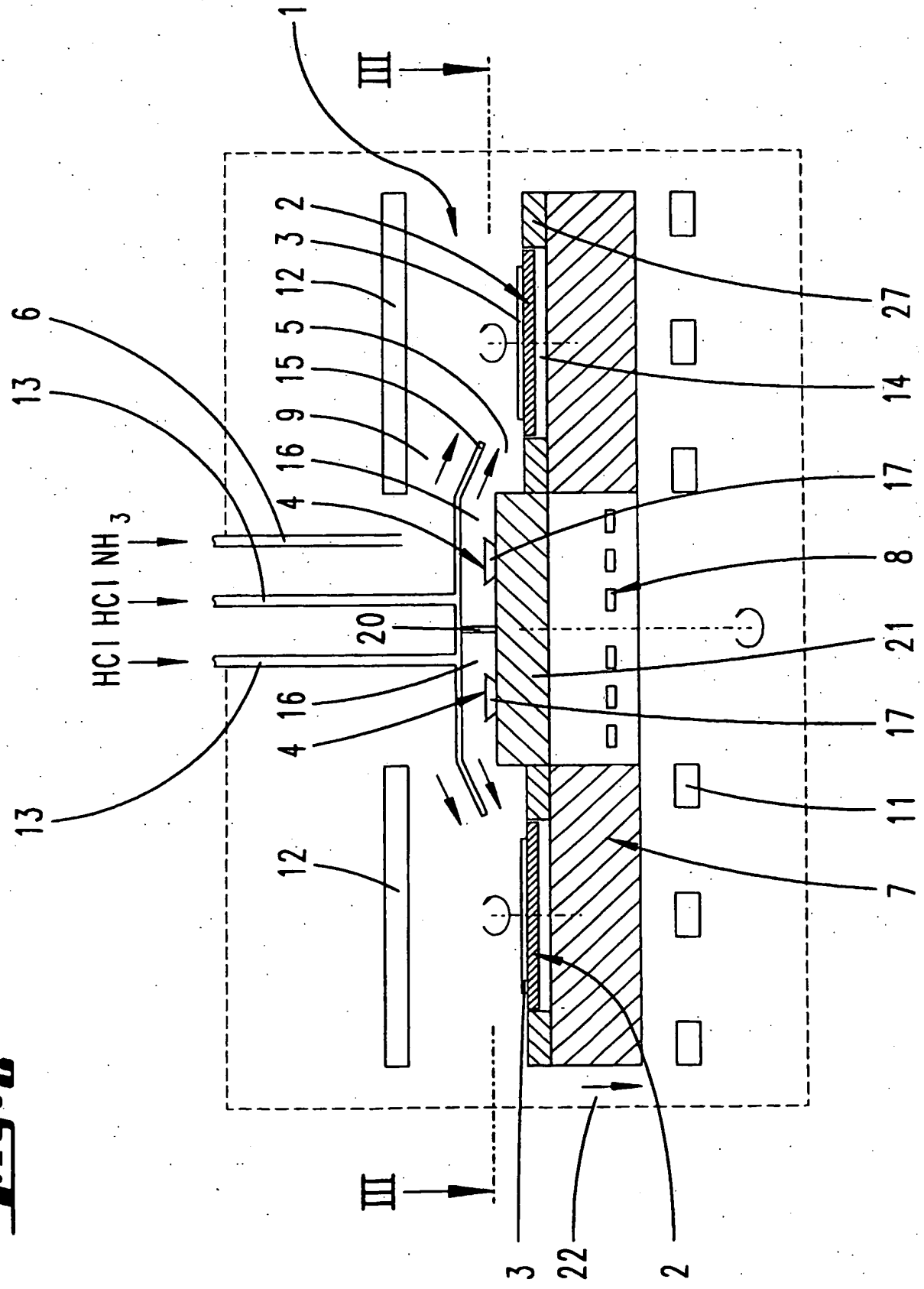
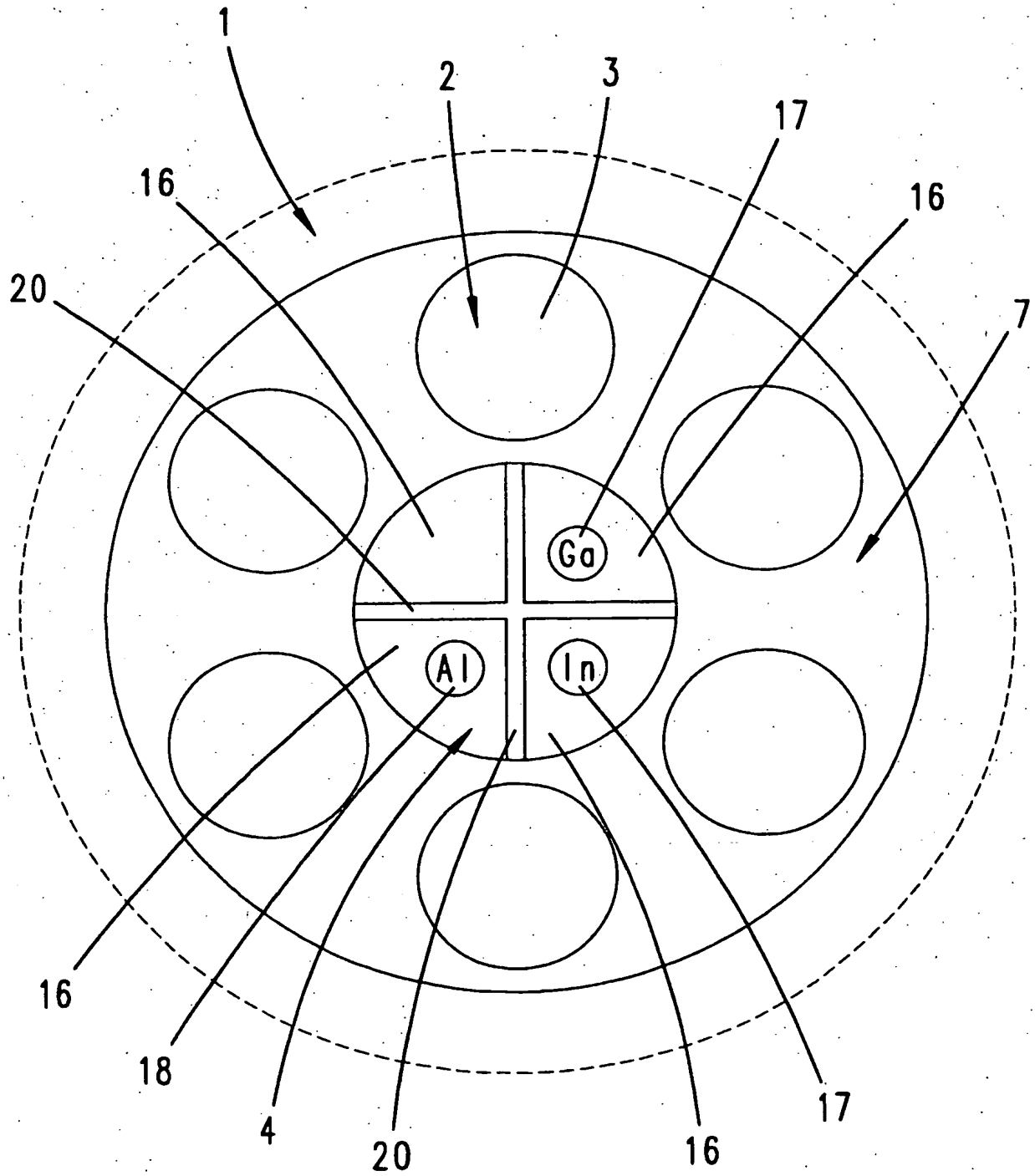

1
III
2
3
12
6
5
15
13
9
16
4
HCl HCl NH3
20
16
4
13
12
27
14
17
8
21
17
11
7
III
3
22
2

Fig.2

Fig. 3



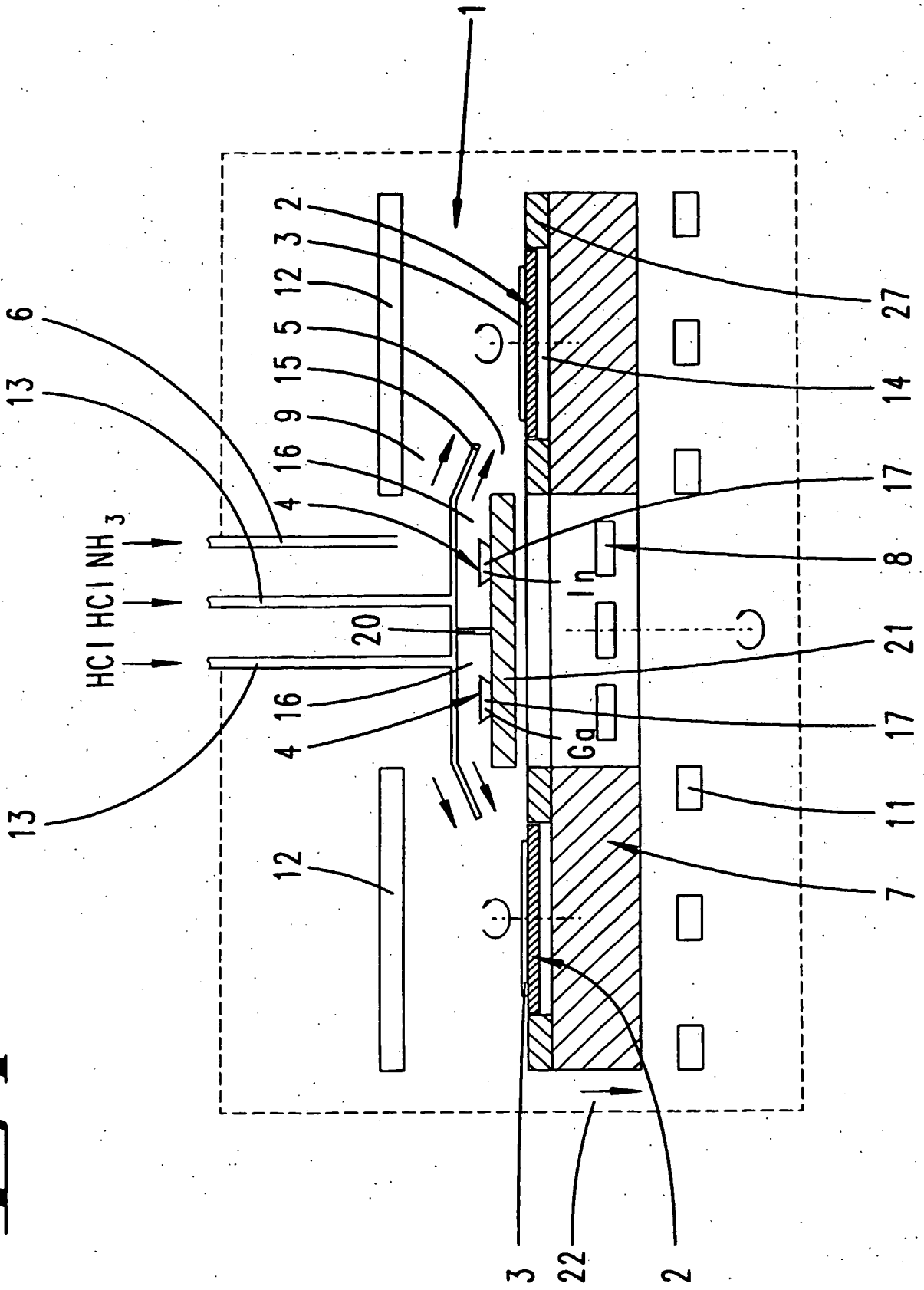

1
2
3
12
5
15
9
16
4
6
13
HCl HCl NH3
20
16
4
13
12
3
22
2
27
14
17
8
In
21
17
Ga
11
7

Fig:4

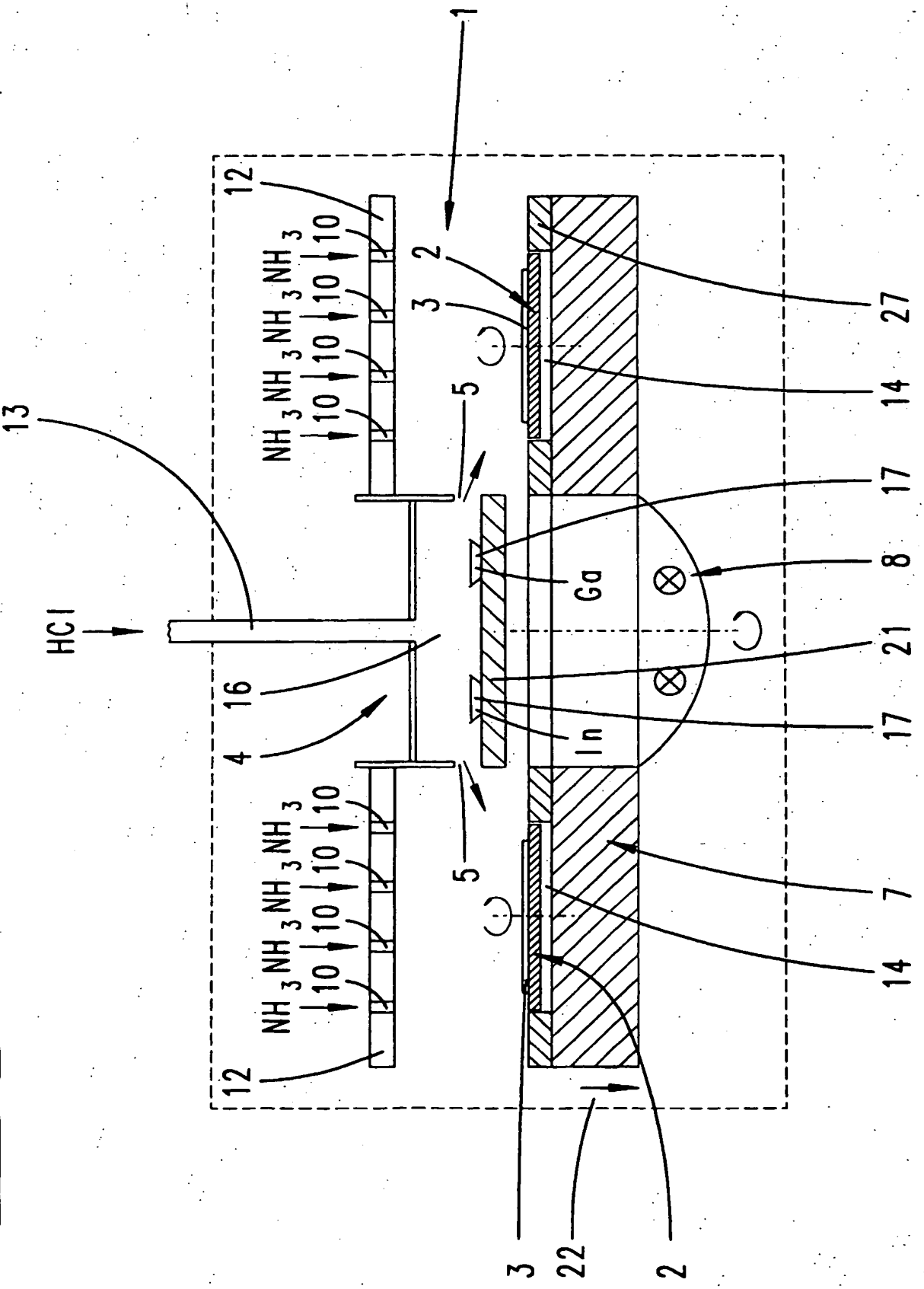


Fig.5

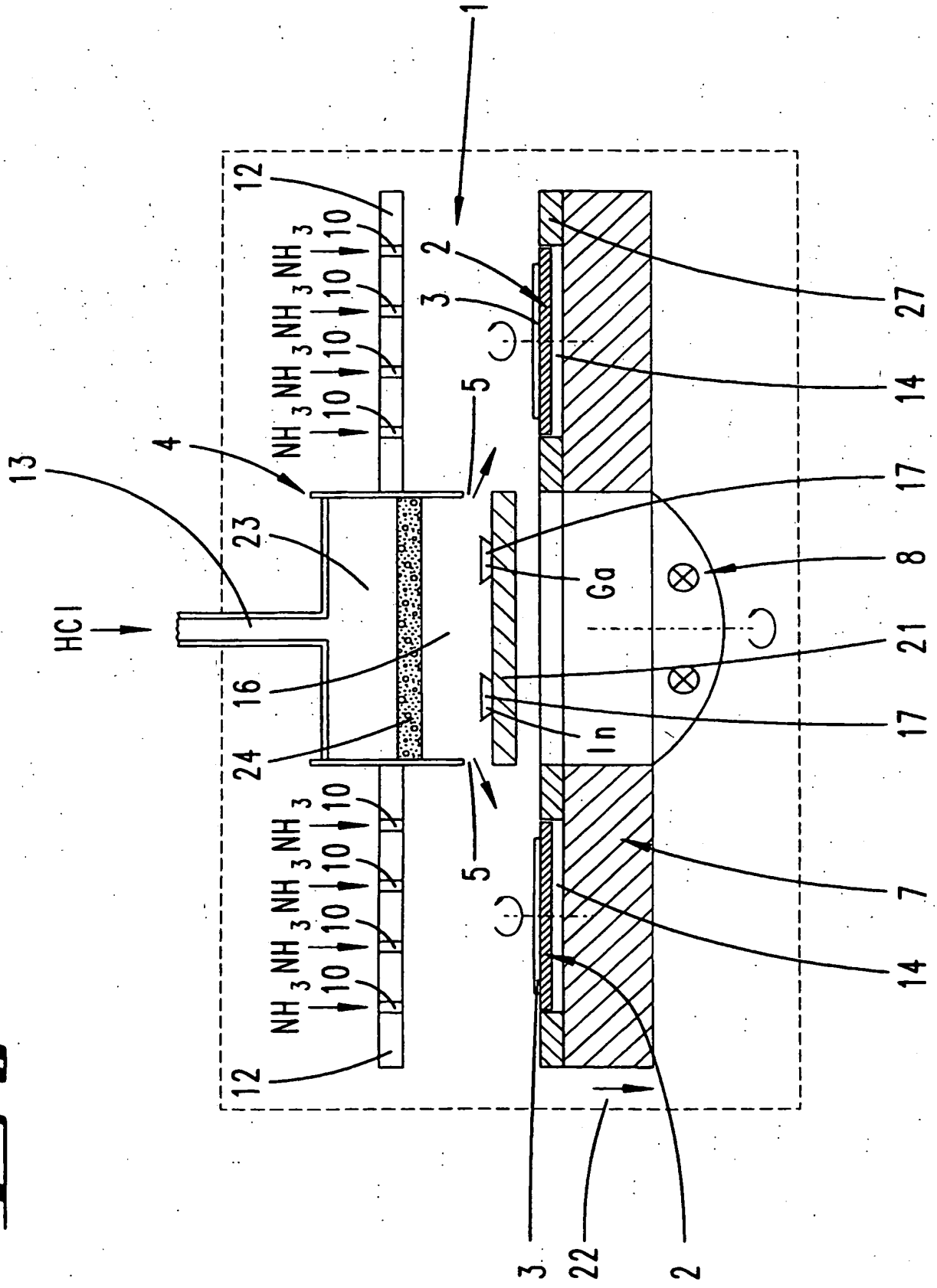


Fig. 6

Fig:7

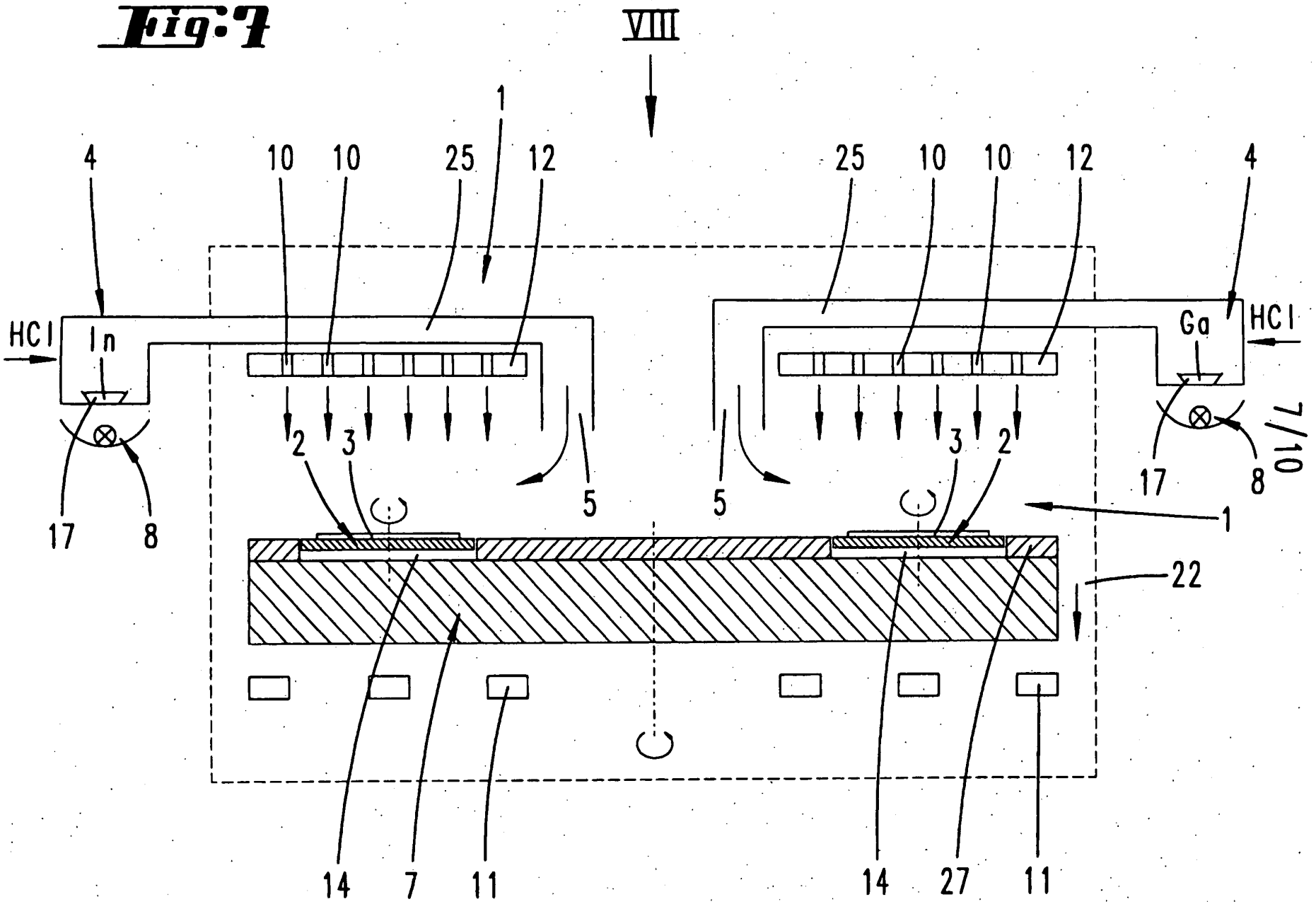

VIII
1
4
10
10
25
12
25
10
10
12
4
HCl
In
Ga
HCl
2
3
3
2
5
5
17
8
17
8
1
22
14
7
11
14
27
11

Fig. 8

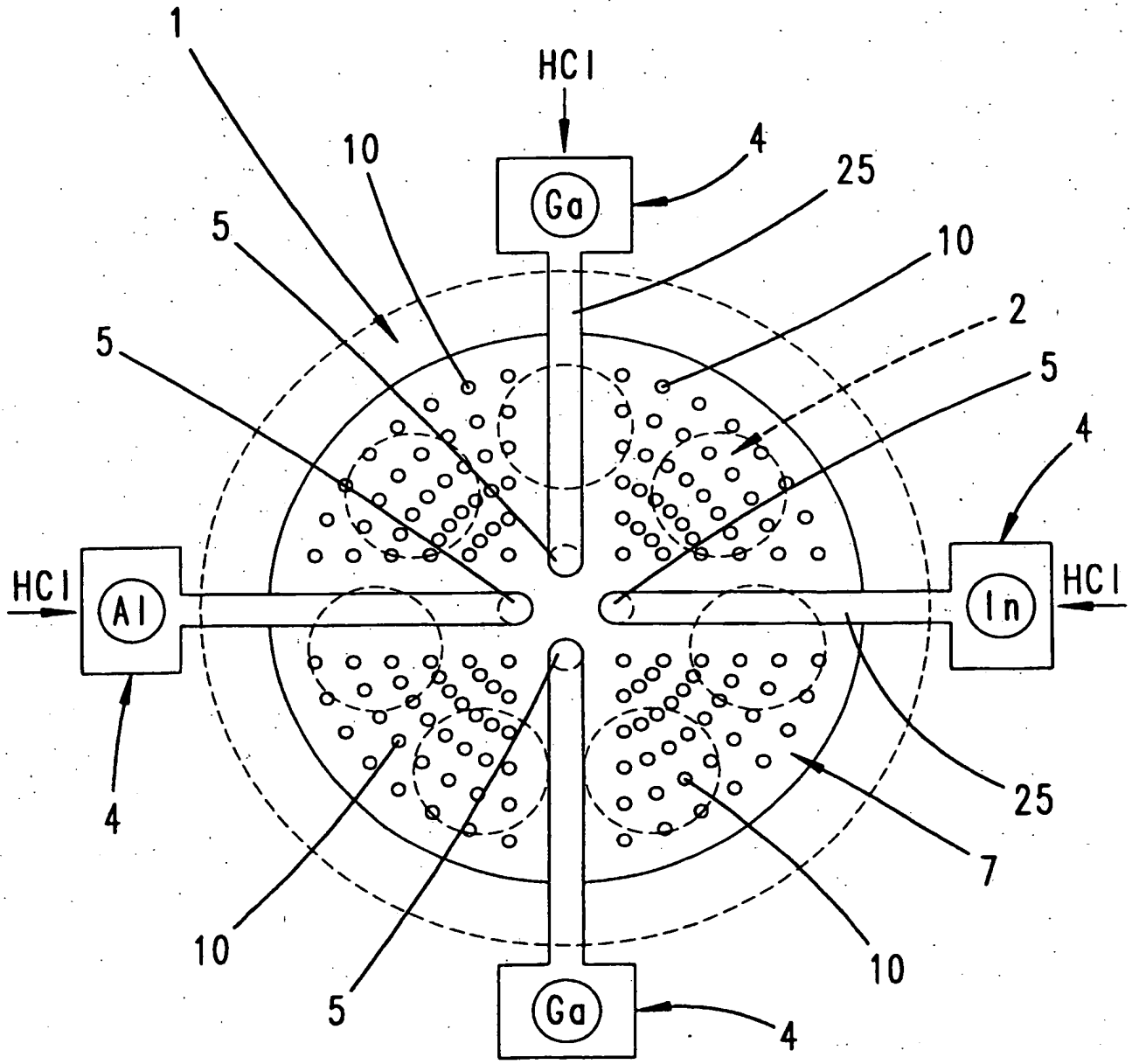


Fig. 9

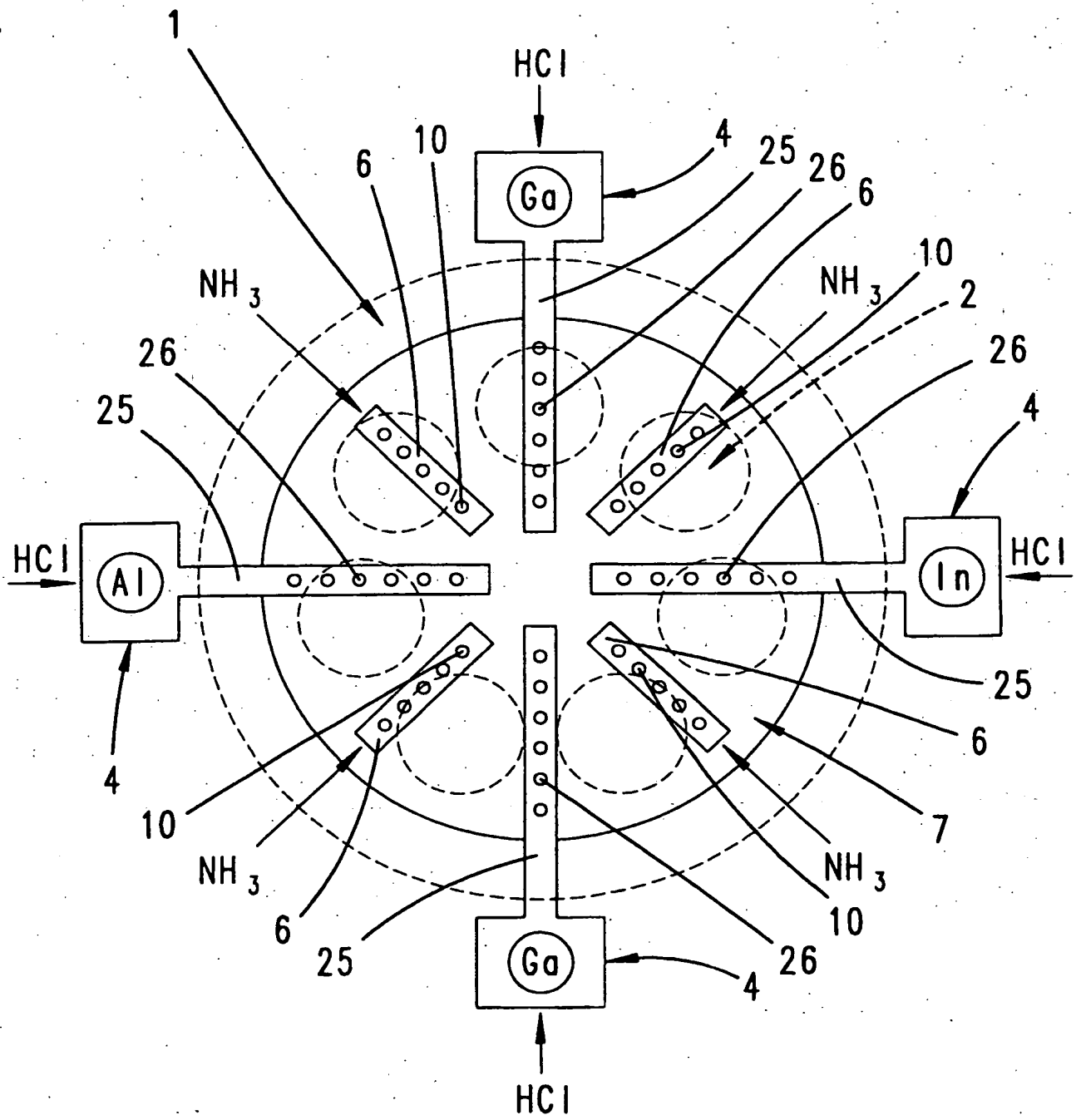

1
HCl
10
6
4
25
26
6
Ga
NH 3
10
NH 3
2
26
26
25
4
HCl
Al
In
HCl
4
25
6
10
7
NH 3
NH 3
6
10
25
26
Ga
4
HCl

Fig. 10

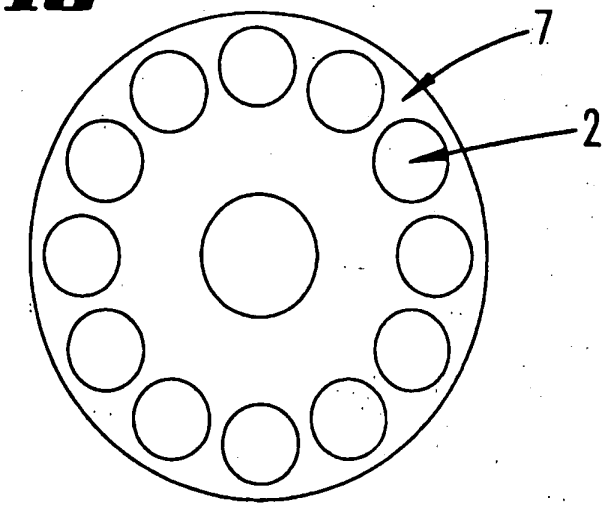


Fig. 11

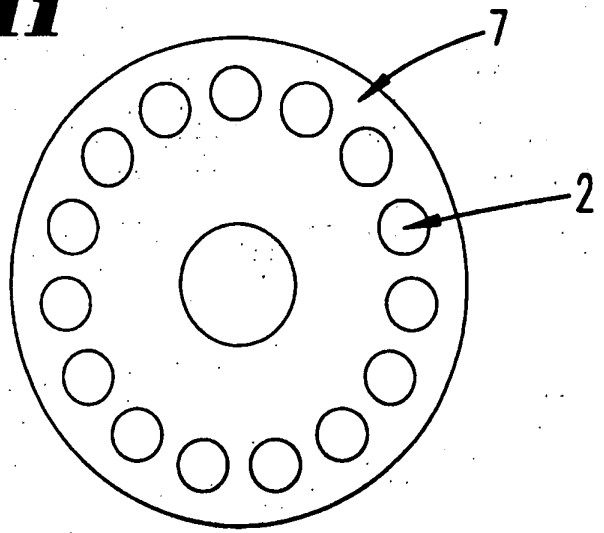


Fig. 12

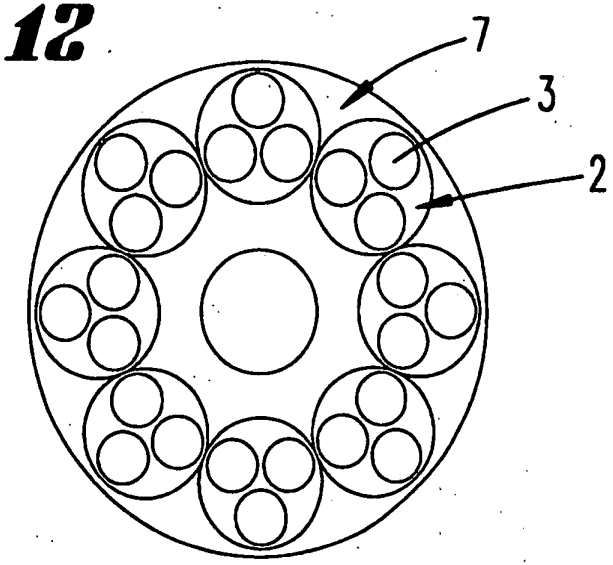
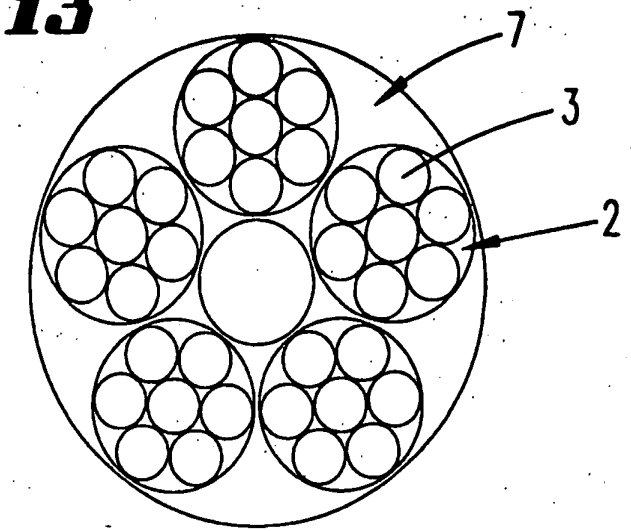



Fig. 13